UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S) LIU, LIANJUN GROUP ART UNIT: 2832
APPLN. NO.: 10/692548 EXAMINER: Bernard Roias

FILED: 10/24/2003

TITLE: METHOD OF MAKING A MICROMECHANICAL DEVICE

Certific	ate of	Subm	iss	ion

I hereby certify that this correspondence is being submitted to the USPTO, Alexandria, VA.

Addressed per C.F.R.§ 1.1(a) and deposited with the United States Postal Service with sufficient postage as first class mail.

Facsimile transmitted in accordance with C.F.R.§1.6(d).

Submitted electronically via EFS in accordance with "Legal

January 24, 2007

Date of Submission

/Dora Hudgins/

Signature

Dora Hudgins
Printed Name of Person Signing Certificate

Framework for EFS Web".

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated November 16, 2006, and Examiner's comments with regard thereto, please enter the following Amendment in the above-entitled application, without prejudice or disclaimer.

If Applicant has overlooked any additional fees, or if any overpayment has been made, the Commissioner is hereby authorized to credit or debit Deposit Account 503079, Freescale Semiconductor. Inc.